RECEIVED CENTRAL FAX CENTER

Attorney Docket No.: SP02-260

SEP 2 2 2005

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor:

BELLMAN, et al.

Serial No:

10/722,769

Filing Date: November 26, 2003

Title:

METHOD USING MULTI-

COMPONENT COLLOIDAL ABRASIVES FOR CMP

PROCESSING OF

SEMICONDUCTOR AND OPTICAL MATERIALS

Group Art Unit: 1765

Examiner: CHEN, Kin Chan

RESUBMISSION

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

RESUBMISSION OF REPONSE TO OFFICIAL ACTION

The Office issued an Office action on the above-identified patent application dated March 3, 2005.

Applicant filed a Response to the Office action on June 3, 2005 ("the Response"), along with a return receipt.

On June 10, 2005, Applicant received the return receipt bearing a stamp of the OIPE, indicating that the Office received the Response on June 6, 2005.

Applicant so far has not received any further action in writing from the Office.

On September 19, 2005, Applicant's counsel received a phone call from the Examiner for this patent application, Mr. Kin Chan Chen, in which Examiner Chen advised that he did not receive a response from Applicant for the Office action of March 3, 2005.

On September 21, Applicant checked the image file wrapper of the application available on www.uspto.gov, and did not see an indication of receipt of the Response by the Office.

Therefore, Applicant is resubmitting herewith a copy of the Response, together with photocopy of the front side and back side of the return receipt bearing the stamp of the OIPE of the Office, via facsimile to (571) 273-8300.

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Applicant believes that no extension of time is necessary to make this Resubmission timely. Should Applicant be in error, Applicant respectfully requests that the Office grant such time extension pursuant to 37 C.F.R. § 1.136(a) as necessary to make this Resubmission timely, and hereby authorizes the Office to charge any necessary fee or surcharge with respect to said time extension to the deposit account of the undersigned firm of attorneys, Deposit Account 03-3325.

The undersigned attorney is granted limited recognition by the Office of Discipline and Enrollment of the USPTO to practice before the USPTO in capacity as an employee of Corning Incorporated.

Please direct any questions or comments to the undersigned at (607) 248-1253.

Date: Septender 22, 2005

Certificate of Facsimile

I hereby certify that this paper and/or fee are being factionaled to the Commissioner of Patents, at (571) 273-

(Date)

Jennifer M. Richtmyer

Respectfully submitted,

CORNING INCORPORATED

Siwen Chen

Limited Recognition No.: L0023

Corning Incorporated Patent Department Mail Stop SP-TI-03-1 Corning, NY 14831

RECEIVED INCORPORATED CENTRAL FAX CENTER

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SEMICONDUCTOR AND **OPTICAL MATERIALS**

RESPONSE

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

RESPONSE TO THE EXAMINER'S RESTRICTION REQUIREMENT

In response to the Office Action dated March 3, 2005 in the above-captioned application, please enter the following Amendments and Remarks.

Amendment to the specification begins at page 2 in this paper.

Amendments to the claims begin at page 3 in this paper.

Remarks begin on page 7 in this paper.